

# SELF-BIAS CONTROL OF ELECTROABSORPTION WAVEGUIDE MODULATOR

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## Abstract

For analog fiber optic links using electroabsorption modulators, the correlation between the RF link gain and the modulator photocurrent is investigated both theoretically and experimentally. Based on this correlation, a self-bias control scheme of the electroabsorption modulator for maximum RF link gain is proposed. This scheme can simplify the bias control of modulator arrays.

## Introduction

Analog fiber optic links can be used to transmit microwave signals in applications such as cable TV, antenna remoting, and active phased arrays. Semiconductor electroabsorption (EA) modulators are useful in these links in view of their potential for low voltage operation, large bandwidth, and monolithic integration with other components.<sup>[1]</sup> RF efficiency and spurious free dynamic range (SFDR) are important figures of merit for analog links and are mainly limited by the modulator. For EA modulators, the RF efficiency and the multi-octave SFDR can be optimized at the same modulator bias.<sup>[2]</sup> However, the optimum modulator bias needs to be adjusted during operation, as the transfer characteristics can change in response to changes in ambient temperature, polarization, and optical power levels. Figure 1 shows a conventional modulator bias control scheme, in which a coupler is used to tap off a portion of the modulated light for examining the RF signal so that the optimal bias can be maintained. However, for modulator arrays, it is highly desirable to employ an approach which can reduce the number of optical components in view of space and fiber alignment considerations.

In this work, we report a novel and greatly simplified approach to control the modulator bias, as depicted in figure 2, which is based upon the correlation between the RF link gain and the modulator photocurrent. We show that, under various operating conditions, the modulator bias at which the modulator photocurrent experiences the largest change with incremental bias tracks closely the bias for the maximum RF link gain. Therefore, using the modulator photocurrent, we can find the optimal modulator bias for maximum RF link gain and multi-octave SFDR.

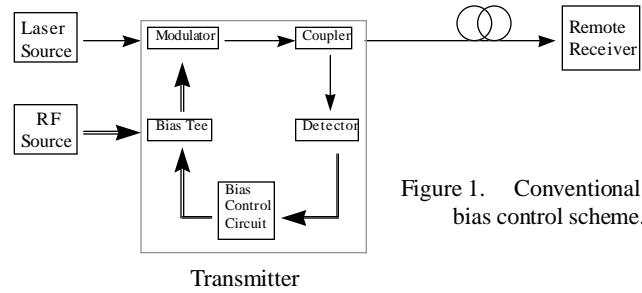


Figure 1. Conventional bias control scheme.

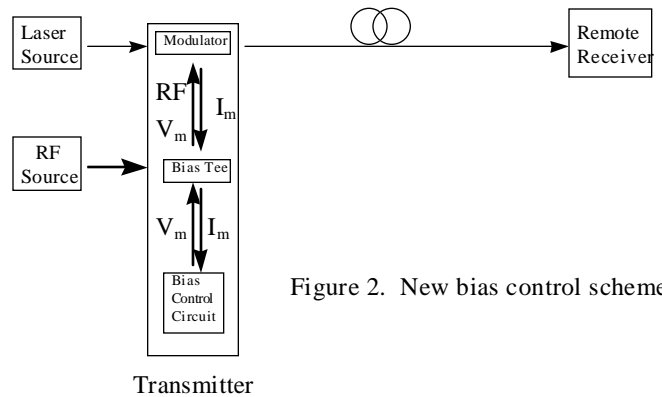


Figure 2. New bias control scheme

## Theory

The above mentioned bias coincidence comes from the correlation among the RF link gain, the modulator transfer curve and the modulator DC photocurrent. The RF link gain is proportional to the square of the slope efficiency of the modulator transfer curve<sup>[3]</sup>, which depicts the modulator transmission versus bias voltage. The modulator transmission is proportional to the modulator absorption, which in turn is proportional to the modulator DC photocurrent. Consequently, the RF link gain is proportional to the square of the change in modulator photocurrent with respect to bias.

The following summarizes the main steps of the derivation.

The total voltage across the modulator is:

$$V = V_m + v_m \quad (1)$$

where  $V_m$  is the modulator DC bias,  $v_m$  is the AC modulation voltage. For an ideal modulator which can be treated as an open circuit, the RF input power is totally reflected, a standing wave builds up in the input transmission line. Therefore  $v_m$  will be twice the input microwave voltage. The relationship between the input RF power  $P_{RF-in}$  and  $v_m$  can be written as:

$$P_{RF-in} = \frac{v_m^2}{4R_{in}} \quad (2)$$

where  $R_{in}$  is the characteristic impedance of the input transmission line. In practice, since the modulator has a finite impedance,  $v_m$  is less than twice the input voltage. We use a factor  $\rho_m$  to account for this modulation reduction effect, and Eq. (2) becomes:

$$P_{RF-in} = \frac{v_m^2}{4\rho_m R} \quad (3)$$

If  $i_d$  is the detected AC current at the end of the fiber link, the output RF power right after the detector is:

$$P_{RF-out} = \rho_d \frac{i_d^2}{2} R_{out} \quad (4)$$

where  $R_{out}$  is the detector output resistance,  $\rho_d$  accounts for the RF power loss including the detector impedance mismatch loss. The RF link gain is obtained from the ratio of (4) to (3):

$$G_{RF} = \frac{P_{RF-out}}{P_{RF-in}} = 4\rho_m \rho_d R R \left( \frac{i_d}{v_m} \right)^2 \quad (5)$$

We obtain  $i_d/v_m$  from the modulator transfer characteristic. The transmission of an EA modulator can be written as:

$$e^{i\alpha} = S_{mm}^{2L} e^{-\Gamma\alpha} \quad (6)$$

where  $S_m$  is the optical loss of the modulator due to scattering;  $L_m$  is the loss due to Fresnel reflection and fiber coupling at each facet;  $\Gamma$  is the optical confinement factor of the modulator absorption layer;  $\alpha$  is the corresponding absorption coefficient;  $L$  is the waveguide length.

The optical power reaching the input facet of the modulator is  $P_o$ , and the optical loss from the modulator to the detector (excluding the modulator) is  $K$ , the total optical power coupled into the detector is:

$$P_{out} = P_o S_{mm}^{2L} e^{-\Gamma\alpha} \quad (7)$$

With the detector DC current calculated from

$$I_d = \eta_d P_{out} \quad (8)$$

where  $\eta_d$  is the detector responsivity, we obtain

$$i_d = \left( \frac{dI_d}{dv_m} \right) v_m = -\eta_d P_o S_{mm}^{2L} K e^{-\Gamma\alpha} \frac{d\alpha}{dv_m} v_m \quad (9)$$

Substituting (9) into (5), the RF gain becomes

$$G_{RF} = 4\rho_m \rho_d R R \eta \left( \frac{d\alpha}{dv_m} \right)^2 e^{-2\Gamma\alpha} \quad (10)$$

Next we derive the modulator DC photocurrent  $I_m$ . The total optical power absorbed by the EA modulator is:

$$P_{ab} = P_o S_m L_m (1 - e^{-\Gamma\alpha}) \quad (11)$$

This gives rise to photocurrent  $I_m$ ,

$$I_m = \eta_m P_{ab} = \eta_m P_o S_m L_m (1 - e^{-\Gamma\alpha}) \quad (12)$$

where  $\eta_m$  is a conversion factor defined as the ratio of the modulator photocurrent to the absorbed optical power. Below saturation  $\eta_m$  is close to  $e/h\nu$ , where  $e$  is the Coulomb charge,  $h\nu$  is the photon energy. Taking the derivative of  $I_m$  with respect to  $V_m$  we get:

$$\frac{dI_m}{dV_m} = \eta_m P_o S_m L_m \Gamma L e^{-\Gamma \alpha L} \frac{d\alpha}{dV_m} \quad (13)$$

Combining Eqs. (10) and (13), we get:

$$G_{RF} = C \left( \frac{dI_m}{dV_m} \right)^2 \quad (14)$$

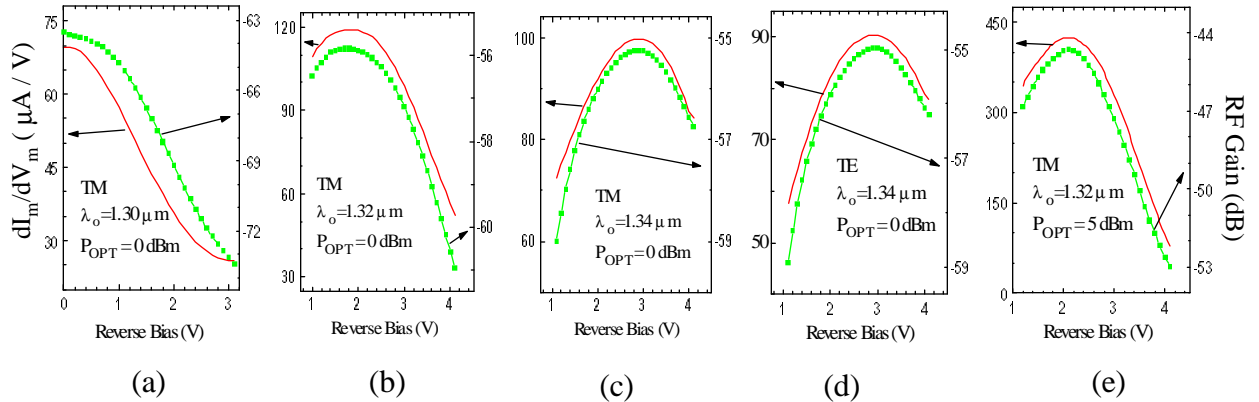
$$\text{where } C = 4\rho_m \rho_d R_{in} R_{out} \left( \frac{L_m K \eta_d}{\eta_m} \right)^2 \quad (15)$$

It should be noted in the expression for  $C$  that only  $\rho_m$ ,  $L_m$  and  $\eta_m$  have possible dependence on  $V_m$ , especially in the case of large optical power coupled into the modulator. At high power, a large density of photo-generated carriers at the absorption region can reduce  $\eta_m$ , especially at small bias.<sup>[4]</sup> Also the absorption layer dielectric permittivity can change due to the high density of carriers, so that the modulator capacitance and optical mode can be affected. Thus  $\rho_m$  and  $L_m$  become dependent on  $V_m$  at high optical power. However, when optical power is well below the modulator saturation power level,  $C$  is essentially a constant, and the bias for maximum  $G_{RF}$  coincides with the bias for maximum  $|dI_m/dV_m|$ . Under this circumstance, the self-bias control

scheme in principle works well. When the optical power approaches the modulator saturation level, this bias control method would need modification.

## Experiment

An InGaAsP/InP Franz-Keldysh effect waveguide modulator is used in this work. The waveguide has a 2.5  $\mu\text{m}$  thick InGaAsP ( $\lambda_Q = 1.26 \mu\text{m}$ ) layer sandwiched between  $p^+$ -InP and  $n^+$ -InP layers. In the 2.5  $\mu\text{m}$  thick InGaAsP layer, the top 1.15  $\mu\text{m}$  is doped p-type, the middle 0.35  $\mu\text{m}$  is undoped, the bottom 1  $\mu\text{m}$  is doped n-type. Waveguide mesa etching is stopped after etching through the undoped InGaAsP layer. The waveguide mesa is 3  $\mu\text{m}$  wide at the top, and is 180  $\mu\text{m}$  long. This large optical cavity structure is designed to allow a good coupling to lensed fibers. At zero bias, the fiber-to-fiber optical insertion loss at 1.34  $\mu\text{m}$  wavelength is measured to be 8 dB without AR coating. We have also observed polarization insensitive operation for maximum RF gain at this wavelength. (See figures 3c and 3d)



Figures 3a-e  $G_{RF}$  versus  $V_m$  and  $dI_m/dV_m$  versus  $V_m$  curves under different operating wavelength, optical power and polarization. In each plot, the left axis is  $dI_m/dV_m$  ( $\mu\text{A/V}$ ), the right axis is RF Gain (dB).

The RF link gain,  $G_{RF}$ , and the modulator photocurrent,  $I_m$ , are measured as a function of modulator bias voltage  $V_m$ . In order to compare the bias point  $V_{m-\max}$  (for maximum  $dI_m/dV_m$ ) with

the bias point  $V_{RF-\max}$  (for maximum RF gain) under different operating conditions, the measurement were repeated using different laser wavelengths (1.30, 1.32 or 1.34  $\mu\text{m}$ ), different

optical power levels (0 and 5 dBm) and different input polarizations (TE and TM). The ambient temperature change is simulated by laser wavelength change, because the major effect of temperature change is to change the detuning energy of the modulator. A 400 Å wavelength change can represent a temperature change of approximately 80 °C in this modulator material.

In figures 3a, 3b and 3c, the input light is TM polarized at 0 dBm optical power. The results show that although  $V_{\text{RF-max}}$  does change substantially for a 400 Å wavelength change, it can be tracked closely by  $V_{\text{m-max}}$ . Similarly, figures 3b and 3e show that  $V_{\text{m-max}}$  and  $V_{\text{RF-max}}$  coincide through the 5 dB optical power change. In figures 3c and 3d, the input light wavelength is 1.34 μm, with 0 dBm optical power. The optimal bias point remains the same when the polarization is switched from TM to TE, so the bias tracking of  $V_{\text{m-max}}$  and  $V_{\text{RF-max}}$  is straightforward. These results are summarized in Table 1.

Table 1: Operating conditions and optimal bias points for each measurement in figures 1.

Figure	3a	3b	3c	3d	3e
Wavelength (μm)	1.30	1.32	1.34	1.34	1.32
Polarization	TM	TM	TM	TE	TM
Optical Power (dBm)	0	0	0	0	5
$V_{\text{RF-max}}$ (V)	0	1.8	2.9	2.9	2.1
$V_{\text{m-max}}$ (V)	0	1.8	2.9	2.9	2.1

We have also conducted measurements at higher optical power and observed that this bias tracking works well up to 13 dBm input for high saturation power devices. We found that  $V_{\text{m-max}}$  and  $V_{\text{RF-max}}$  will gradually deviate when the

optical power is close to the modulator saturation power level.

## Conclusion

We have shown that for an electroabsorption modulator, the bias point  $V_{\text{m-max}}$  for the largest slope in modulator DC photocurrent with respect to modulator bias, coincides with the bias point  $V_{\text{RF-max}}$  for achieving the maximum RF link gain. As  $V_{\text{RF-max}}$  drifts due to changes in operating conditions such as temperature, polarization and optical power levels, it can be tracked by a circuit which determines the bias voltage  $V_{\text{m-max}}$ . This approach can facilitate the bias control of an electroabsorption modulator for maintaining maximum RF gain in an analog fiber optic link.

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